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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Antonius Henricus Maria Raaijmakers et al.
Serial No.: 09/745,914
For: ELECTRO-OPTICAL DEVICE HAVING AN ITO LAYER,
A SiN LAYER AND AN INTERMEDIATE SILICON
OXIDE LAYER
Filed: December 22, 2000
Examiner: Chung, David Y.
Group Art Unit: 2871

Attorney Docket No.: PHN 17,819

Mail Stop: AF
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

AMENDMENT RESPONSE

Dear Sir:

In response to the Office Action dated October 6, 2003,
please amend the above-noted application as follows:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 4 of this paper.